



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/712,775 Group Art Unit: 1765

Filing Date: November 14, 2003 Examiner: Anita K. Alanko

Applicant: Donggyun Han et al.

Title: APPARATUS AND METHOD FOR REMOVING
PHOTORESIST FROM A SUBSTRATE

Attorney Docket: 2557-000216/US

Customer Service Window
Randolph Building
401 Dulany Street
Alexandria, VA 22314
Mail Stop Amendment

September 15, 2006

PRELIMINARY AMENDMENT

Sir:

The following amendments and remarks are respectfully submitted in connection with the above-identified application.

Amendments to the Claims begin on page 2 of this Amendment.

Remarks begin on page 8 of this Amendment.

| | Claims remaining after Amendment | | Highest number previously paid for | | Present extra |
|--------------------|-------------------------------------|---|---------------------------------------|---|---------------|
| Total | 40 | - | 50 | = | 0 |
| Independent | 3 | - | 4 | = | 0 |